

Notice of References Cited				Application No. 09/361,980		Applicant(s) Ito et al.	
				Examiner Lynette T. Umez-Eronini		Group Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	NAME		CLASS	SUBCLASS
A						
B						
C						
D						
E						
F						
G						
H						
I						
J						
K						
L						
M						

FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N	63,062,746 A	3/1998	Japan	Nagahata	347	200
O	03,012,960 A	1/1991	Japan	Iida	257	537
P						
Q						
R						
S						
T						

NON-PATENT DOCUMENTS	
	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)
U	Nagahata, Preparation of Thermal Head, English Abstract of JP 63062746 A, 2 pages.
V	Iida, Semiconductor Device and Manufacture Thereof, English Abstract of JP 3012960 A, 2 pages.
W	
X	